

GEMOLOGICAL INSTITUTE

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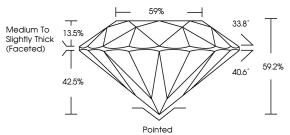
LABORATORY GROWN DIAMOND REPORT

PROPORTIONS

June 24, 2024					
IGI Report Number	LG638417271				
Description	LABORATORY GROWN DIAMOND				
Shape and Cutting Style	ROUND BRILLIANT				
Measurements	6.85 - 6.91 X 4.07 MM				
GRADING RESULTS					
Carat Weight	1.16 CARAT				
Color Grade	F ICI ST F				
Clarity Grade	VS 1				
Cut Grade	IDEAL				
ADDITIONAL GRADING INFORMATION					

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	(G) LG638417271

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



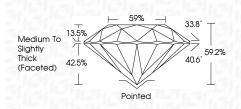
LG638417271

Report verification at igi.org



Sample Image Used

	June 24, 2024		
LG638417271	IGI Report Number		
RATORY GROWN DIAMOND	Description LABOR		
ROUND BRILLIANT	Shape and Cutting Style		
6.85 - 6.91 X 4.07 MM	Measurements		
	GRADING RESULTS		
1.16 CARAT	Carat Weight		
E.	Color Grade		
VS 1	Clarity Grade		
IDEAL	Cut Grade		



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	1671 LG638417271
Comments: This Laboratory created by Chemical Vapo process. Type IIa	

COLOR

Red symbols indicate internal characteristics. Green symbols indicate external characteristics.

DEFGHIJ Faint Very Light Light CLARITY VVS ^{1 - 2} VS 1-2 SI 1 - 2 1.3 IE Very Internally Very Very Slightly Included Slightly Included Flawless Slightly Included Included



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une 34, 2024 (Gl Report No Le63841727) RONND BRILLIANT 6.85 - 6.91 X, 407 MM Corret Weight 1, 16 CARAI Concer Weight 1, 16 CARAI	Grade VS ade IDEA	Depth 55.2% Table 65% Grade Medum to Slightly Grade Thick (Facefed)	Culet Pointec Polish EXCELLEN Symmetry EXCELLEN Fluorescence (1991) (691) (6404) 1727)	Commants: Labordory Rown Demond was restade by Chemical Vapor Deposition (CMD) growth process. type lig
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CLARITY CHARACTERISTICS